Effect of plasma treatment on the gas sensor with single-walled carbon nanotube paste

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A B S T R A C T
The effect of plasma treatment on the gas sensing properties of screen-printed single-walled carbon nanotube (SWCNT) pastes is reported. The gas sensors, using SWCNT pastes as a sensing material, were fabricated by photolithography and screen printing. The SWCNT pastes were deposited between inter-digitated electrodes on heater membrane by screen printing. In order to functionalize the pastes, they were plasma treated using several gases which produce defects caused by reactive ion etching. The Ar and O₂ plasma-treated SWCNT pastes exhibited a large response to NO₂ exposure and the fluorinated gas, such as CF₄ and SF₆, plasma-treated SWCNT pastes exhibited a large response to NH₃ exposure.

1. Introduction

Single-walled carbon nanotubes (SWCNTs) are promising materials for upcoming highly sensitive gas sensors, due to their low operating temperature and low power consumption. For practical applications, a versatile, simple, fast, and cost-effective coating technique is needed for mass production. In large scale fabrication of SWCNT sensors, direct growth of nanotubes by chemical vapor deposition involves difficult handling of individual nanotube with low throughput. This method also requires a high growth temperature. On the other hand, screen printing, using printable paste is more appropriate for mass production [1].

In order to enhance the gas sensing characteristics of the screen-printed SWCNT pastes, functionalization of the nanotube surface is required. Previously, it has been reported that defect sites can give rise to stronger interactions with adsorbed molecules. Therefore, functionalized SWCNT sensors can often offer higher sensitivity and better selectivity compared to pristine SWCNT sensors [2–4].

Generally, in order to modify the surface characteristics of nanotubes, various methods have been used, such as electrochemical [5], and chemical functionalization [6–8], fluorination [9,10], polymer wrapping [11], and plasma treatment [12–15]. Plasma treatment offers several advantages, including a nonpolluting process and operating conditions at room temperature, which are especially important for industrial applications.

In this work, SWCNT pastes were deposited onto the electrodes through screen printing. In order to functionalize the pastes, they were then plasma treated using several gases. Finally the responses of the plasma-treated SWCNT pastes when exposed to test gases were measured. The results suggest that wafer level fabrication of gas sensors is plausible through screen printing of SWCNT pastes which have been plasma treated. In addition, the interaction of the absorbed molecules with the SWCNT pastes was enhanced.

2. Experimental

2.1. SWCNT paste preparation

Purified pristine SWCNT powders were purchased from Unidym, Inc., USA. The powders were mixed in an agate mortar for 1 h with Ethyl cellulose and α-terpineol to make a printable paste. The weight ratio of CNTs:Ethyl cellulose:α-terpineol was 1:9:90. The mixed SWCNT paste was then further crushed and dispersed through a 3-roll mill.
Table 1

<table>
<thead>
<tr>
<th>Plasma gas</th>
<th>Work pressure (mTorr)</th>
<th>Gas flow rate (sccm)</th>
<th>Etch time (s)</th>
<th>RF power (W)</th>
<th>Purity (%)</th>
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<tr>
<td>Ar</td>
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<tr>
<td>SF₆</td>
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2.2. Fabrication of SWCNT paste gas sensor

The schematic of our sensor is shown in Fig. 1(a). The device, integrated with a micro-heater, was fabricated on Si wafer with all of the patterning processes performed by photolithography. Initially, a low-stress SiNx layer was deposited on the wafer using low pressure chemical vapor deposition (LPCVD). In order to create the micro-heater, Ti/Pt were then deposited by e-beam evaporation and patterned. An oxide-nitride-oxide layer was deposited by plasma enhanced chemical vapor deposition to provide electrical insulation between the electrode and the micro-heater. As for the electrodes, Ti/Au were deposited by sputtering and then patterned. In addition, the backside of the silicon was etched by a KOH etchant to generate thermally insulated heater membranes. Finally, the mechanically well-dispersed SWCNT paste was screen printed onto the wafer. Although the membrane is more prone to stress, SWCNT paste was successfully deposited. The wafer was then heated in an oven at 90 °C for 15 min to remove the solvent. After dicing the wafer, heat treatment was performed in a gas chamber using the micro-heater at 380 °C in a nitrogen atmosphere in order to burn out the organic binder in the SWCNT paste on each sensor. The images of fabricated sensor are shown in detail in [16], and the scanning electron microscopy (SEM) image of the heat treated SWCNT paste is presented in Fig. 1(b).

2.3. Plasma treatment and measurement

The plasma treatment was carried out in a reactive ion etching system. The chamber was evacuated to less than $5 \times 10^{-5}$ Torr. After the pressure of the chamber had stabilized to the proper value, RF glow discharge was used to make the reactive plasmas. Ar, O₂, CF₄, and SF₆ gases were consecutively introduced into the chamber for the plasma treatment. The experimental parameters are itemized in Table 1.

In order to investigate the effect of the plasma treatment on the SWCNT pastes, we analyzed the Raman spectra of the SWCNT paste samples after plasma treatment with different gases. The intensity ratio between the D-band and the G-band ($I_D/I_G$) were estimated to allow a quantitative assessment of the disorder density in the SWCNT using the D-band and the G-band features. The tests were carried out in a sealed chamber with a volume of 1 L. NO₂ and NH₃ were used as test gases and the concentration of the test gases were diluted with N₂. The concentration of the test gases was varied by adjusting the ratio of the flow rate of the test gases and N₂ on the mass flow controllers. The total flow rate during gas sensing was set at 200 sccm. And during recovery cycle, N₂ with flow rate of 500 sccm was used to purge the chamber. The resistance change of the sensors was measured and stored using LabVIEW software and Keithley 2400.

3. Results and discussion

3.1. Raman spectroscopy

Raman spectroscopy is a very useful tool for exploring the characteristics of SWCNTs. One of the interesting features of the Raman spectra in carbon materials is that the linear laser excitation energy is dependent on the frequency of the D-band and the G-band.

The D-band, at around 1300 cm⁻¹, is a disorder feature induced by the first-order scattering and the double resonance Raman process [17–20]. The D-band is usually attributed to the presence of amorphous or disordered carbon in the SWCNTs. The carbon structural disorder is caused by the presence of defects, dangling bonds, grain boundaries, vacancies, and hetero-atoms on the SWCNT walls. The tangential G-band, at around 1600 cm⁻¹, originates either from the single-resonance first-order or from the vibrations along the nanotube axis and circumferential directions [17,21].

In Fig. 2, the Raman spectra of the pristine and plasma-treated SWCNT pastes with a 514.5 nm laser line in the 1100–1800 cm⁻¹ frequency range are shown. The G-band intensity was normalized with respect to the intensity of the D-band. The spectra show that the integral structure of the nanotubes was maintained under all of the plasma conditions showing typical resonant Raman features for SWCNT, and also the double-peak structure typical for SWCNTs around the G-band. The peak at 1580 cm⁻¹ was stronger than that found at 1520 cm⁻¹ for all of the Raman spectra, especially in the plasma-treated SWCNT pastes, which confirms that the characteristics of the predominant semiconducting nanotubes [17].

In addition, the enhancement of the $I_D/I_G$ ratio (Table 2) could be clearly observed after the plasma treatment. This is attributed to the defects and the functionalization of the nanotube surface. It is well known that during plasma treatment, excited species,
such as radicals, electrons, ions, and UV light, interact with the nanotube surface, breaking C–C bonds and creating active sites for the bonding of functional groups [22]. Consequently, the conversion of sp2-hybridized carbon to a sp3-hybridized carbon on the surface occurs, resulting in an increase in the disorder mode due to functionalization and a decrease in the C–C tangential mode due to the loss of electronic resonance. Therefore, we concluded that the predominant semiconducting characteristics, along with the defect generation and functionalization are caused by the plasma treatment.

3.2. Operation of SWCNT paste sensor

We calculated the response $S$ as $[(R_g − R_0)/R_0] \times 100$, where $R_g$ represents the resistance upon exposure to the test gases and $R_0$ is the initial resistance in the presence of N2.

Figure 3(a) and (b) shows the operation of the pristine SWCNT paste gas sensor at room temperature with 5 ppm NO2 and 100 ppm NH3 exposure, respectively. The response of the sensor was measured by exposing to test gases and N2 alternately at every 20 min. The resistance of the sensor was decreased when exposed to NO2 and increased when exposed to NH3 because the adsorption of the electron withdrawing (NO2) or the donating (NH3) molecules on the pristine SWCNT pastes caused a charge transfer between the pristine SWCNT pastes and the test gas molecules. This result shows that the pristine SWCNT paste exhibits p-type behavior. In addition, the recovery time was very long due to the higher bonding energy between the pristine SWCNT pastes and the test gas molecules. Hence, the sensor resistance did not return to the initial value for 20 min. Such results were also observed in previous publications [23,24].

3.3. NO2 adsorption in pristine and plasma-treated SWCNT pastes

Figure 5 shows the response of the SWCNT pastes exposed to 5 ppm NO2 at room temperature. In the case of Ar plasma-treated SWCNT (Ar-SWCNT) paste, the response was larger compared to that of the pristine SWCNT paste. Such enhancement can be attributed to an increase in defect sites on the nanotube in the Ar-SWCNT pastes caused by ion bombardment during plasma treatment. The response of O2 plasma-treated SWCNT (O2-SWCNT) paste was also enhanced, and was the most sensitive among the pastes. For the O2-SWCNT paste, the defect sites and other oxygen related groups caused by oxidation reaction led to improvements in the response to NO2 exposure. Previous experimental work proved that the uppermost layer of the O2-SWCNT contains carbonyl (C=O), hydroxide (C–OH) and carboxyl (COOH) groups revealed through
pastes were modulated by the fluorinated gas plasma. This propensity in the change in resistance was consistent with B-doped SWCNTs when exposed to NO2 [27]. Bai and Zhou suggested that NO2 is chemisorbed on the B-doped SWCNT and this strong bonding causes an empty level above the valence band maximum (VBM). Therefore the band structure of the SWCNT is altered, and the conductance of this p-type semiconductor is decreased.

It is known that fluorine forms a variety of very different compounds, because of its small atomic size and covalent behavior. However, the C–F bond is highly polarized, forming a significant electrostatic attraction between C+ and F− rather than the usual covalent bond [28]. Accordingly, the F-SWCNT paste was more hole-doped causing the resistance of the NO2-attached F-SWCNT paste to increase similar to the NO2-attached B-doped SWCNT.

3.4. NH3 adsorption in pristine and plasma-treated SWCNT pastes

Fig. 6 shows the response of the SWCNT pastes exposed to 100 ppm of NH3 at room temperature. The theoretical studies indicate a weak interaction between pristine SWCNTs and NH3, with little charge transfer [29,30]. Therefore, the pristine SWCNT paste was less responsive to NH3 than to NO2 exposure. Upon exposure to NH3, all of the plasma-treated SWCNT pastes exhibited an enhanced response compared to that of the pristine SWCNT paste. In addition, Fig. 6 shows that different plasma treatment other than NO2 could improve the response of the SWCNT paste gas sensors when exposed to NH3. However, only slight changes in response were observed for the Ar and O2-SWCNT pastes, which lead to the fact that the effects of the defect sites and the oxygen containing groups on NH3 molecules were less significant than anticipated.

Conversely, the F-SWCNT pastes displayed significant enhancements in response to NH3 exposure. This significant increase in response is attributed to the fact that the adsorption energies and charge transfers were caused by the C–F bonds on the F-SWCNT pastes. The result was also consistent with the properties of B-doped SWCNTs [27]. Bai and Zhou have suggested that since a localized half-filled level appears above the VBM, a lone pair of NH3 electrons fills the empty level in the VBM and forms an acceptor level above the VBM. The acceptor level is higher for the B-doped SWCNT without any NH3 attachments, and hence the conductance of a B-doped SWCNT which is also a p-type semiconductor will decrease upon NH3 exposure. As mentioned above, the C-F bond was highly polarized, and therefore the resistance change of the NH3-attached F-SWCNT paste was further increased compared to that of the pristine SWCNT paste.

Among the F-SWCNT pastes, the response of the SF6 plasma-treated SWCNT paste was the most reactive upon NH3 exposure.
It shows that the SWCNT paste treated by SF6 plasma was more fluorinated. This result is consistent with the results from previous report [26].

3.5. Selectivity of the pristine and plasma-treated SWCNT pastes

For practical use, the selectivity of the gas sensor is also an important consideration. A comparison between the responses of the sensors for different gases is shown in Fig. 7. It is found that the plasma treated SWCNT pastes exhibit larger response to NO2 and NH3, but less or no response at all to CO (oxidizing gas) and C2H5OH (reducing gas). It is clear that the SWCNT pastes are highly selective to NO2 and NH3.

4. Conclusions

The electrical responses to NO2 and NH3 molecules found in screen-printed SWCNT pastes on the membrane structure treated by various plasma gases have been experimentally investigated.

For the NO2 adsorption, it was found that the SWCNT pastes treated by Ar and O2 plasmas were more sensitive than pristine SWCNT paste, due to oxidation and the presence of defects on the nanotube surface. However, the SWCNT pastes functionalized with fluorinated gases such as CF3 and SF6 were less sensitive. Apparently, the presence of fluorine atoms on the nanotube surface modified the electronic structure of the SWCNT.

NH3 adsorption was found to be responsive to the plasma treated SWCNT pastes. In this case, fluorinated plasma-treated SWCNT pastes showed a larger response than oxidized and defective SWCNT pastes, due to the presence of fluorine atoms that improve the charge transfer from the NH3 molecules to the SWCNT.

It was also observed that the different responses of the plasma-treated SWCNT pastes for NO2 and NH3 exposure depend on the structural defects and functional groups present in the SWCNT surface. This work confirmed and highlighted the fact that SWCNT paste was successfully deposited on the membrane by screen printing. In addition, plasma treatment on SWCNT paste has significant effects on the enhancement in the response of the gas sensors.

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